



3742

Attorney Docket No. 0756-2412

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11/5/03  
CJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Serial No. 10/021,708

Filed: December 19, 2001

For: HEAT TREATMENT APPARATUS  
AND METHOD OF  
MANUFACTURING A  
SEMICONDUCTOR DEVICE

) Group Art Unit: 3742

) Examiner: S. Fuqua

) CERTIFICATE OF MAILING

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RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner of Patents  
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TECHNOLOGY CENTER R3700

Sir:

Alexandria, VA 22313-1450

Sir:

Further in response to the Official Action dated September 30, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 26 of this paper.